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Attorney's Docket No. 008209/USA/FEP/GCM/RKK

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Pravin K. Narwankar, et al.

Serial No. 10/772,893

Filed: February 4, 2004

For: Tailoring Nitrogen Profile In Silicon
Oxynitride Using Rapid Thermal
Annealing With Ammonia Under
Ultra-Low Pressure

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

) Examiner: Unassigned

) Art Unit: Unassigned

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Sir:

Please change the correspondence address of the above-identified patent application to the following person and address:

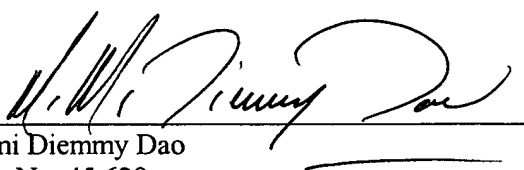
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Please update the Patent Office records to reflect the new correspondence address and telephone number.

Respectfully submitted,

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Date: June 14, 2004


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BSTZ Docket No. 004887.P776